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**Stabilization of Organic Electronic  
Materials and Devices**



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Volume 33, Number 13, July 14, 2018

## STABILIZATION OF ORGANIC ELECTRONIC MATERIALS AND DEVICES

- 1839–1840 **The path to ubiquitous organic electronics hinges on its stability** Christoph Brabec, Hans-Joachim Egelhaaf, Michael Salvador

## INVITED ARTICLES

- 1841–1852 **Methodology of the first combined in-flight and ex situ stability assessment of organic-based solar cells for space applications** Dieter Schreurs, Steven Nagels, Ilaria Cardinaletti, Tim Vangerven, Rob Cornelissen, Jelle Vodnik, Jaroslav Hruby, Wim Deferme, Jean V. Manca
- 1853–1859 **Degradation kinetics in different polymer–fullerene blends investigated by electron spin resonance** Marek Havlicek, Niyazi Serdar Sariciftci, Markus C. Scharber
- 1860–1867 **High-temperature stable single carrier hole only device based on conjugated polymers** Shahidul Alam, Peter Fischer, Christian Kästner, Chetan R. Singh, Ulrich S. Schubert, Harald Hoppe
- 1868–1878 **New insights into polymer solar cells stability: The crucial role of PCBM oxidation** Anthony Perthu , Th r se Gorisse, Hugo Santos Silva, Christian Lombard, Didier B gu , Pi trick Hudhomme, Brigitte P pin-Donat, Agn s Rivaton, Guillaume Wantz
- 1879–1890 **Photocrosslinking of low band-gap conjugated polymers using alkyl chloride sidechains: Toward high-efficiency, thermally stable polymer solar cells** Chi Zhang, Steven Holdcroft
- 1891–1901 **PMMA as an effective protection layer against the oxidation of P3HT and MDMO-PPV by ozone** Andreas Fr h, Hans-Joachim Egelhaaf, Holger Hintz, Dustin Quinones, Christoph J. Brabec, Heiko Peisert, Thomas Chass 
- 1902–1908 **Stability study of thermal cycling on organic solar cells** Harrison Ka Hin Lee, James R. Durrant, Zhe Li, Wing Chung Tsoi

(Continued)

1909–1924 **Stability of organic solar cells with PCDTBT donor polymer: An interlaboratory study**

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Ricardo Oliveira, Ana Charas,  
Tulus, Elizabeth von Hauff,  
Giuseppina Polino,  
Francesca Brunetti,  
Rickard Hansson, Ellen Moons,  
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George Kakavelakis,  
Emmanuel Kymakis,  
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Vida Turkovic,  
Horst-Günter Rubahn,  
Morten Madsen,  
Vaidotas Kažukauskas,  
David M. Tanenbaum,  
Santhosh Shanmugam,  
Yulia Galagan

1925–1936 **Encapsulation requirements to enable stable organic ultra-thin and stretchable devices**

Vera Steinmann, Lorenza Moro